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PTO/SB/17 (12-04)

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FEE TRANSMITTAL For FY 2005 <small>Effective on 12/1/2005 Fees pursuant to the Consolidated Appropriations Act, 2005 (H.R. 4818)</small>		Complete if Known	
		Application Number	09/864,309
		Filing Date	May 25, 2001
		First Named Inventor	Shigeyuki UZAWA et al.
		Examiner Name	R. A. Jarrett
<input type="checkbox"/> Applicant claims small entity status. See 37 C.F.R. 1.27		Art Unit	2125
TOTAL AMOUNT OF PAYMENT		Attorney Docket No.	00862.022239
(\$) 0.00			

METHOD OF PAYMENT (check all that apply)

☐ Check ☐ Credit Card ☐ Money Order ☐ None ☐ Other (please identify): _____

☒ Deposit Account Deposit Account Number: 06-1205 Deposit Account Name: Fitzpatrick, Cella, Harper & Scinto

For the above-identified deposit account, the Director is hereby authorized to: (check all that apply)

☐ Charge fee(s) indicated below ☐ Charge fee(s) indicated below, **except for the filing fee**

☒ Charge any additional fee(s) or underpayments of fee(s) under 37 C.F.R. 1.16 and 1.17 ☒ Credit any overpayments

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FEE CALCULATION

1. BASIC FILING, SEARCH, AND EXAMINATION FEES

Application Type	FILING FEES		SEARCH FEES		EXAMINATION FEES		Fees Paid (\$)
	Small Entity	Fee (\$)	Small Entity	Fee (\$)	Small Entity	Fee (\$)	
Utility	300	150	500	250	200	100	
Design	200	100	100	50	130	65	
Plant	200	100	300	150	160	80	
Reissue	300	150	500	250	600	300	

2. EXCESS CLAIM FEES

Fee Description	Small Entity	Fee (\$)
Each claim over 20 or, for Reissues, each claim over 20 and more than in the original patent	50	25
Each independent claim over 3 or, for Reissues, each independent claim more than in the original patent	200	100
Multiple dependent claims	360	180

Total Claims **Extra Claims** **Fee (\$)** **Fee Paid (\$)** **Multiple Dependent Claims**

14 - 47 (HP) = 0 x 50.00 = 0.00 **Fee (\$)** **Fee Paid (\$)**

HP = highest number of total claims paid for, if greater than 20

Indep. Claims **Extra Claims** **Fee (\$)** **Fee Paid (\$)**

1 - 9 (HP) = 0 x 200.00 = 0.00

HP = highest number of independent claims paid for, if greater than 3

3. APPLICATION SIZE FEE

If the specification, drawings, and any Preliminary Amendment exceed 100 sheets of paper in total, the application size fee due is \$250 (\$125 for small entity) for each additional 50 sheets or fraction thereof. See 35 U.S.C. 41(a)(1)(G) and 37 CFR 1.16(s).

Total Sheets **Extra Sheets** **Number of each additional 50 or fraction thereof** **Fee (\$)** **Fee Paid (\$)**

 - 100 = / 50 = (round up to a whole number) x 250.00 =

4. OTHER FEE(S)

Non-English Specification, \$130 fee (no small entity discount) **Fees Paid (\$)**

Other: _____

SUBMITTED BY			
Signature		Registration No. 33,326 (Attorney/Agent)	Telephone 202-530-1010
Name (Print/Type)	Steven E. Warner		Date: April 20, 2006

This collection of information is required by 37 CFR 1.136. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 30 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions

00862.022239



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: R. A. Jarrett
Shigeyuki UZAWA et al.)	
	:	Group Art Unit: 2125
Application No.: 09/864,309)	
	:	Confirmation No.: 2803
Filed: May 25, 2001)	
	:	
For: EXPOSURE APPARATUS, COATING/DEVELOPING)	
SYSTEM, DEVICE MANUFACTURING SYSTEM,	:	April 20, 2006
DEVICE MANUFACTURING METHOD,)	
SEMICONDUCTOR MANUFACTURING FACTORY,	:	
AND EXPOSURE APPARATUS MAINTENANCE)	
METHOD	:	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated January 20, 2006, please amend the above-identified application as follows: